



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasufumi NISHII et al.

Group Art Unit: 2851

Application No.: 10/582,268

Examiner: M. LIU

Filed: June 9, 2006

Docket No.: 128375

For: STAGE APPARATUS, EXPOSURE APPARATUS, AND EXPOSURE METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 26, 2008 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**